

SEPPS 001AUS

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

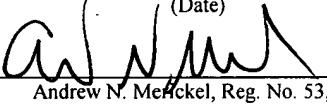
Applicant : Skarp et al.
Appl. No. : 10/003,749
Filed : October 23, 2001
For : PROCESS FOR PRODUCING
ALUMINUM OXIDE FILMS AT
LOW TEMPERATURES
Examiner : Bret P. Chen
Group Art Unit : 1762

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 22, 2003

(Date)


Andrew N. Meckel, Reg. No. 53,317AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED
OCT 31 2003
TC 1700

Dear Sir:

The present paper is submitted in response to the Office Action mailed on June 3, 2003 and is accompanied by a request for a two-month extension of the time for responding. Applicants respectfully request entry of the following amendments and consideration of the subsequent remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

10/29/2003 ZJUHAR1 00000055 10003749

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